IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Adkisson et al

Serial No. 09/691,353

Filed: October 18, 2000 Title: METHOD OF FABRICATING

SEMICONDUCTOR SIDE WALL FIN

Docket: BUR919990300US1 Date: December 20, 2001

Art Unit: 2823

Examiner: Deven M. Collins

Response to Restriction Requirement

Commissioner of Patents & Trademarks Washington, D.C. 20231

Sir:

In response to the Restriction Requirement of November 30, 2001, the applicant hereby elects Group L claims 1 and 14-23, without traverse.

Respectfully submitted,

12/20/2001

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